

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasushi OKUBO et al.

Application No.: 10/551,136

Filed: January 5, 2006

Docket No.: 125493

For: MASK BLANK, MASK BLANK MANUFACTURING METHOD, TRANSFER MASK
MANUFACTURING METHOD, AND SEMICONDUCTOR DEVICE
MANUFACTURING METHOD

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

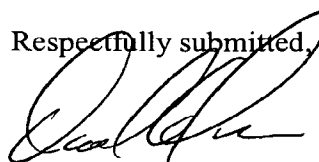
Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of the non-English language reference 3 is discussed in the present specification.
- ☒ 3. The references were cited in the International Search Report. An English language version of the International Search Report is attached for the Examiner's information.
- ☒ 4. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /SR/

- ☒ 5. English language Abstracts of the non-English language references 3-9 are attached hereto.
- ☒ 6. A computer-generated English language translation of the following Japanese Patent Publication has been obtained from the website of the Japanese Patent Office ([<http://www.jpo.go.jp>]), and is attached, but has not been reviewed for accuracy. See References 3-5 and 8.
- ☒ 7. Reference 1 corresponds to reference 3. Reference 2 corresponds to reference 4.

Respectfully submitted,



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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
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Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 125493		APPLICATION NO. 10/551,136	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANTS Yasushi OKUBO et al.			
				FILING DATE January 5, 2006			
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
	1.	US 2002/0000424 A1	1/3/2002	Hata			
	2.	US 2002/0052100	5/2/2002	Tanaka et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
	3.	JP A 2001-259502 (w/abstract and translation)	9/25/2001	Japan			
	4.	JP A 2002-131883 (w/abstract and translation)	5/9/2002	Japan			
	5.	JP A 5-53290 (w/abstract and translation)	3/5/1993	Japan			
	6.	JP A 64-86520 (w/abstract)	3/31/1989	Japan			
	7.	JP A 1-125828 (w/abstract)	5/18/1989	Japan			
	8.	JP A 8-17708 (w/abstract and translation)	1/19/1996	Japan			
	9.	JP A 4-40456 (w/abstract)	2/10/1992	Japan			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
EXAMINER /Stephen Rosasco/				DATE CONSIDERED 10/15/2008			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /SR/

Date: January 5, 2006